

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: Koji NOZAKI et al.

Group Art Unit: 1752

Serial No.: 10/623,679

Examiner: Amanda C. Walke

Filed: July 22, 2003

Confirmation No.: 5083

For:

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RESIST PATTERN THICKENING MATERIAL, RESIST

PATTERN AND PROCESS FOR FORMING THE SAME, AND

SEMICONDUCTOR DEVICE AND PROCESS FOR

MANUFACTURING THE SAME

Attorney Docket Number: 030891

Customer Number: 38834

Date: May 25, 2005

PETITION FOR EXTENSION OF TIME

Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated January 25, 2005 for one month from April 25, 2005 to May 25, 2005.

Attached please find a check in the amount of \$620.00 (\$500.00 for the notice of appeal and \$120.00 for the extension of time for a large entity). If any additional fees are due in connection with this paper, please charge our Deposit Account No. 50-2866.

Respectfully submitted,

WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP 05/26/2005 JADD01 00000005 10623679

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Limited Recognition

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